

## Corres. and Mail BOX AF

## RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 2825

Docket No.: 1081.1137

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yoshimasa IIDUKA, et al.

Serial No. 10/073,246

Group Art Unit: 2825

Confirmation No. 4438

Filed: February 13, 2002

Examiner: Yelena Rossoshek

For:

EXPOSURE METHOD UTILIZING OPTICAL PROXIMITY CORRECTED EXPOSURE

PATTERNS, AN APPARATUS FOR GENERATING OPTICAL PROXIMITY

CORRECTED EXPOSURE DATA, AND AN EXPOSURE APPARATUS FOR OPTICAL

PROXIMITY CORRECTED EXPOSURE DATA

## AMENDMENT UNDER 37 C.F.R. § 1.116

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Attention: BOX AF

Sir:

This is in response to the Office Action mailed January 18, 2005, and having a period for response set to expire on April 18, 2005. A Petition for a one-month extension of time, together with the requisite fee for same, is submitted herewith, thereby extending the period for response to May 18, 2005. The following amendments and remarks are respectfully submitted.

Reconsideration of the claims is respectfully requested.

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